

(TiAlSi)N 中熵涂层的微观组织与力学性能研究

张亚南, 张 豪, 周子超, 肖宇琦, 邓 娜, 付彬芸, 多树旺

(江西科技师范大学材料与机电学院 江西省材料表面工程重点实验室, 江西 南昌 330013)

[摘 要] 为提升机械零件表面涂层的防护效用,结合中熵合金的独特设计理念,采用等离子体增强磁控溅射(PEMS)技术在316L不锈钢表面沉积(TiAlSi)N涂层。使用X射线能谱仪(EDS)、X射线衍射仪(XRD)、场发射扫描电子显微镜(FE-SEM)和原子力显微镜(AFM)分析涂层的化学成分、晶体结构、微观形貌和表面粗糙度。使用纳米划痕/压痕仪测试涂层的结合强度、硬度和弹性模量。EDS分析结果表明(TiAlSi)N为中熵陶瓷涂层。(TiAlSi)N涂层为非晶态,涂层表面平整致密,并且具有良好的力学性能,其结合强度、硬度和弹性模量分别约为25 N、21 GPa和225 GPa。试验结果可为未来深入研究该类涂层体系提供有价值的参考。

[关键词] 等离子体增强磁控溅射; 中熵合金; (TiAlSi)N涂层; 微观结构; 纳米压痕

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Microstructure and Mechanical Properties of (TiAlSi)N Medium Entropy Coatings

ZHANG Ya-nan, ZHANG Hao, ZHOU Zi-chao, XIAO Yu-qi, DENG Na, FU Bin-yun, DUO Shu-wang

(Jiangxi Key Laboratory of Surface Engineering, School of Materials and Mechanical & Electrical Engineering,

Jiangxi Science and Technology Normal University, Nanchang 330013, China)

Abstract: In order to improve the protective effect of the surface coating of mechanical parts, combining with the unique design concept of medium entropy alloy, (TiAlSi)N coatings were deposited on surface of 316L stainless steel by plasma enhanced magnetron sputtering (PEMS). The chemical composition, crystal structure, micro-morphology and surface roughness of coatings were analyzed using X-ray energy dispersive spectrometer (EDS), X-ray diffractometer (XRD), field emission scanning electron microscope (FE-SEM) and atomic force microscope (AFM). The bonding strength, hardness and elastic modulus of the coatings were tested with nano scratch / indentation instrument. EDS analysis results showed that (TiAlSi)N coating was a medium entropy ceramic coating. (TiAlSi)N coatings possessed an amorphous structure, a smooth and compact surface, and good mechanical properties. The bonding strength, hardness and elastic modulus were 25 N, 21 GPa and 225 GPa, respectively. These experimental results would provide a valuable data reference for further future research on this kind of coating systems.

Key words: PEMS; medium entropy alloy; (TiAlSi)N coating; microstructure; nanoindentation

0 前 言

(TiAlSi)N 纳米复合涂层具有高硬度、强附着力、低摩擦系数及优异的抗高温氧化性能^[1-6],成为国内外的研究热点,并且已经在工业领域得到了广泛应用。该涂层通常为非晶态 Si₃N₄包裹着结晶态(Ti, Al)N 的复合结构(nc-TiAlN/a-Si₃N₄),该结构使(TiAlSi)N 涂层具有卓越的力学性能和热学性能^[1, 7-12]。随着科技的发展和工业的进步,开发综合性能更加优异的涂层

材料是当务之急^[13]。

中熵合金是近年来在非晶合金和高熵合金的基础上开发的一种具有广阔应用前景的新型合金。同高熵合金类似,通过适当的组元设计,中熵合金可以获得诸多优异性能,如高热稳定性、高硬度、耐磨耐蚀、抗高温氧化等^[14-20]。此外,与高熵合金相比,中熵合金具有组分简单、成分易控等优点,这表明将“中熵”引入新型智能涂层设计具有一定的可行性。

常用的涂层制备技术有电弧离子镀、离子束、磁控

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[通信作者] 张 豪(1986-),副教授,主要研究方向为陶瓷涂层与薄膜材料,E-mail:zhangyinghao1985@126.com;
多树旺(1975-),教授,主要研究方向为PVD硬质涂层的制备与应用,E-mail:swduo@126.com

溅射等,其中磁控溅射技术具有沉积范围广、靶材种类多、涂层纯度高、膜基结合牢及成分易控制等优点,在工业领域得到广泛应用^[21-24]。然而,传统磁控溅射技术金属离化率低,溅射粒子多以原子态存在,涂层综合性能不佳。等离子体增强磁控溅射(Plasma Enhanced Magnetron Sputtering, PEMS)技术在传统磁控溅射系统的基础上引入热钨丝作为电子发射源^[25],能够提高金属离化率及涂层沉积效率,采用 PEMS 技术可望提升现有涂层的综合性能。鉴于此,结合本课题前期研究,本工作通过多靶共溅射方式,采用 PEMS 技术在 316L 不锈钢表面沉积 (TiAlSi)N 中熵陶瓷涂层,并详细研究了涂层的化学成分、微观组织、晶体结构、结合强度、显微硬度等性能。

1 试 验

使用 MS650B 型回旋式磁控溅射系统在尺寸 15 mm×10 mm×2 mm 的 316L 不锈钢表面沉积 (TiAlSi)N 涂层。选用纯度为 99.99% 的 Al 靶、Si 靶和纯度为 99.7% 的 Ti 靶作为镀膜材料(规格 416 mm×106 mm×12 mm)。溅射气体为高纯氩气,反应气体为高纯氮气。首先对基体材料磨抛和丙酮、乙醇超声清洗,并吹干装炉。为进一步去除基体表面污染物,在 Ar 气氛下,当本底真空优于 3×10^{-3} Pa 时,偏压清洗基体 30 min。此外,Ar⁺轰击还可活化基体表面,有利于后续制备涂层与基体的良好结合。为减缓应力影响,进一步增强涂层与基体间的附着力,沉积 (TiAlSi)N 涂层前,先在基体表面预沉积 Ti 结合层和 TiN 过渡层。(TiAlSi)N 涂层制备工艺参数如下:本底气压 3×10^{-3} Pa,工作气压 0.5 Pa,沉积温度 300 ℃,基体偏压 -50 V,氮气流量 40 mL/min,氩气流量 60 mL/min,沉积时间 180 min,钛靶功

率 1 000 W,硅靶功率 250 W,铝靶功率 125 W。采用 INCA X 射线能谱仪(EDS)分析涂层的化学组成。采用 XRD-6100 X 射线衍射仪(XRD)分析涂层的晶体结构,扫描速度为 2 (°)/min。为减弱基体的影响,采用 D8 ADVANCE 掠入射 XRD 进一步分析 (TiAlSi)N 涂层的晶体结构,掠入射角为 0.5°。采用 SIGMA 场发射扫描电子显微镜(FE-SEM)观察涂层的表、截面形貌。采用 CSPM5500 原子力显微镜(AFM)在轻敲模式下记录涂层的三维形貌及表面粗糙度。采用 NANOVEA PB1000 微纳力学测试系统测试涂层的结合强度、硬度和弹性模量。

2 结果与讨论

2.1 涂层的化学组成

EDS 测试结果显示,(TiAlSi)N 涂层中 Ti、Al、Si、N 元素的原子分数依次为 18.6%,16.3%,14.7%,50.4%。显然,涂层中合金元素和氮元素相对原子含量比约为 1:1,且各合金元素的原子含量比也接近于等摩尔比。基于 Boltzmanm 理论,N 种元素以等摩尔比形成合金,其构型熵 ΔS_{conf} 可以根据式(1)来计算^[26]:

$$\Delta S_{\text{conf}} = -k \ln W = R \left(\frac{1}{N} \ln N + \frac{1}{N} \ln N + \cdots + \frac{1}{N} \ln N \right) = R \ln N \quad (1)$$

式中, k 为玻尔兹曼常数; W 为体系混乱度; R 为摩尔气体常数,8.314 J/(mol·K)。本研究中,涂层的构型熵为 1.1*R*,介于 1.0*R*~1.5*R* 之间,说明采用 PEMS 技术成功制备了 (TiAlSi)N 中熵涂层。

2.2 涂层的显微形貌

图 1 展示了 (TiAlSi)N 中熵涂层的微观形貌。

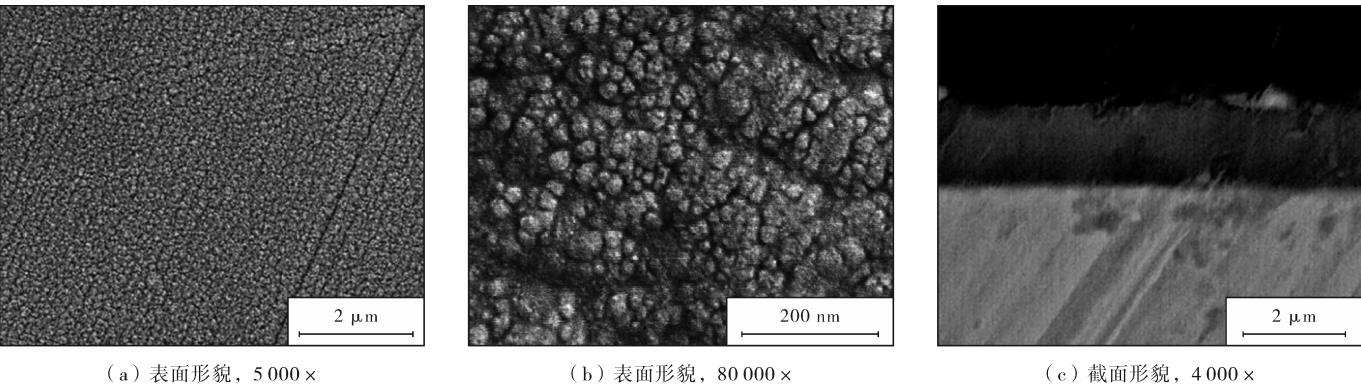


图 1 (TiAlSi)N 中熵涂层的显微形貌
Fig. 1 Morphologies of (TiAlSi)N medium entropy coating

从涂层的低倍率表面形貌中可以看出涂层表面平整致密,并且在涂层表面观察到基体磨抛时留下的犁

痕。高倍率 SEM 照片表明涂层呈纳米结构,涂层表面颗粒尺寸均为纳米级,未观察到明显的裂纹、孔洞等缺

陷。这可能与涂层中含有 Si 元素及中熵涂层中具有相对较高的混合熵有关^[27, 28]。从涂层的截面形貌可以看到涂层总厚度约为 1.5 μm, 厚度均匀, 与基体结合良好。由于 Ti 结合层及 TiN 过渡层很薄, 未观察到清晰的层界。

为了进一步研究 (TiAlSi)N 涂层的显微结构, 采用 AFM 在轻敲模式下分析了涂层的三维形貌及表面粗糙度, 如图 2 所示。从图中可以看出, (TiAlSi)N 涂层表面光滑平整, 晶粒细小, 这与 SEM 观察结果基本吻合, 其表面平均粗糙度仅为 6.53 nm。

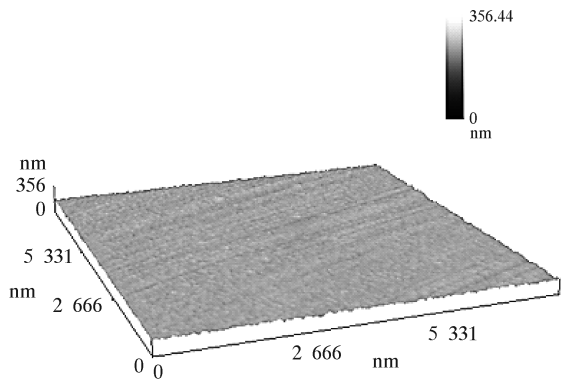


图 2 (TiAlSi)N 涂层的三维表面形貌
Fig. 2 3D surface morphology of (TiAlSi)N coating

2.3 涂层的晶体结构

图 3 给出了 (TiAlSi)N 涂层的 XRD 谱。由图可以看出涂层的衍射花样主要由 1 个宽化的馒头峰和若干个强基体峰组成。涂层较薄 (~1.5 μm), 因此在涂层的衍射花样中检测到非常强的基体衍射峰。宽化的馒头峰表明 (TiAlSi)N 涂层为非晶态结构。为了验证 (TiAlSi)N 涂层的晶体结构, 采用掠入射 XRD 进一步分析了 (TiAlSi)N 涂层的衍射花样。掠入射法减弱了基体影响, 但涂层的衍射花样仍为馒头峰。为了进一步检验 (TiAlSi)N 涂层为非晶结构的论断, 将 (TiAlSi)N

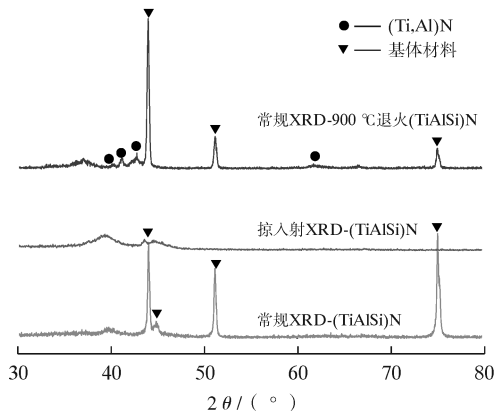


图 3 (TiAlSi)N 涂层的 XRD 谱
Fig. 3 XRD patterns of (TiAlSi)N coating

涂层在 900 °C 的真空环境中恒温处理 12 h, 然后分析其 XRD 谱。经过真空热处理之后的 (TiAlSi)N 涂层 XRD 谱中除了馒头峰和基体峰外, 还观察到一些较弱的 (Ti, Al)N 衍射峰, 这进一步佐证了本研究获得的 (TiAlSi)N 涂层为非晶态。此外, 在所有的 XRD 谱中均没有发现 Si 及其化合物的衍射峰, 说明 Si 以非晶形式存在于涂层中。Si 的加入抑制了 (Ti, Al)N 生长, 涂层晶粒细化或呈现无定形态^[28]。

2.4 涂层的力学性能

涂层与基体之间的结合强度是决定涂层可靠性及其使用寿命的关键指标之一。较高的结合强度可以有效防止涂层剥落, 延长其服役寿命。采用划痕法测试 (TiAlSi)N 涂层与基体之间的结合性能, 金刚石压头划透涂层并使之从基体表面连续剥离时的最小载荷即为膜基结合失效的临界载荷^[29]。划痕测试结果如图 4 所示。载荷连续变化, 当载荷约为 17 N 时, 涂层表面开始出现点状剥落; 当载荷约为 21 N 时, 点状剥落面积增大。随着载荷逐渐增大至接近 25 N 时, 涂层失效由点状剥落转为连续剥落, 大块基体裸露出来 (图 4 中亮白色物质)。基于划痕测试原理, 可以得出 (TiAlSi)N 涂层的结合强度约为 25 N。

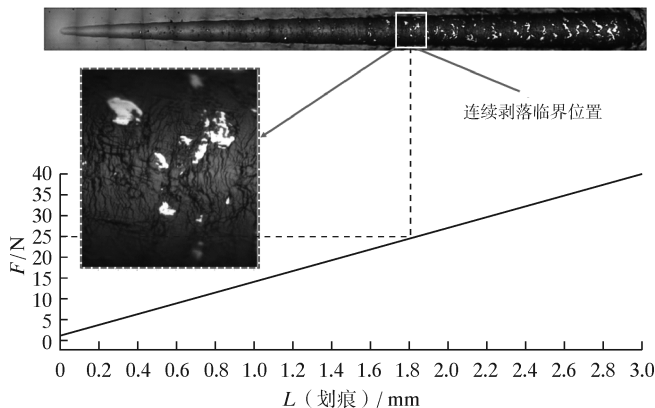


图 4 (TiAlSi)N 涂层划痕测试结果
Fig. 4 Scratch test result of (TiAlSi)N coating

硬度是材料抵抗外来物造成的穿透、变形、刮擦和侵蚀性能的关键指标。弹性模量决定了涂层的应变容限能力, 而应变容限与涂层中残余热应力紧密相关。因此, 硬度和弹性模量也是反映涂层可靠性的重要指标。采用压痕法在涂层表面随机选取 9 个区域测试涂层的硬度及弹性模量, 然后求取平均值。结果显示, (TiAlSi)N 涂层具有相对较高的表面硬度 (21 GPa) 和弹性模量 (225 GPa)。结合涂层形貌及晶体结构分析结果可知, 涂层表面颗粒细小, 涂层平整致密, 并且 Si 的加入有可能在涂层中形成 Si₃N₄ 非晶相, 其细晶强化

作用机制会进一步提高涂层的硬度及弹性模量^[25], 因此(TiAlSi)N 涂层展示出较高的硬度和较大的弹性模量。

3 结 论

采用等离子体增强磁控溅射技术制备了(TiAlSi)N 中熵陶瓷涂层。涂层呈非晶态, 涂层表面光滑平整, 颗粒尺寸细小且排列紧密, 表面粗糙度较低。纳米压痕/划痕测试结果表明涂层具有优良的综合力学性能。该工艺操作简便, 组分易控, 发展中熵合金涂层技术在工业领域具有潜在的应用前景。

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